

Diagram illustrating a cross-sectional view of a semiconductor device. The structure shows a substrate 50 with a P+ region. A layer 55 is on top, with a P region. A series of structures are formed on top of 55, including regions labeled 51, 52, 53, 54, 55, 30, 33, 35, N, N+, and P-.

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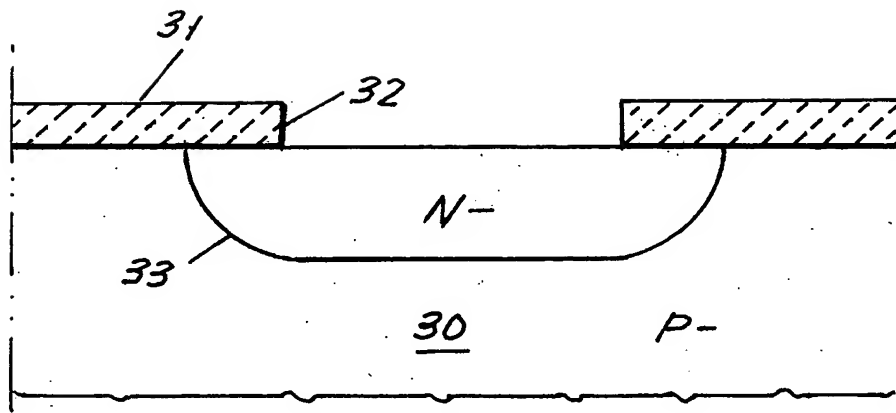


FIG. 2

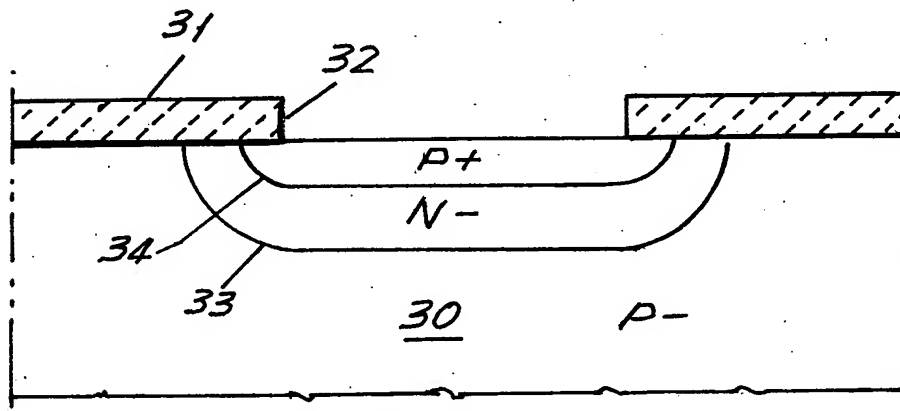


FIG. 3

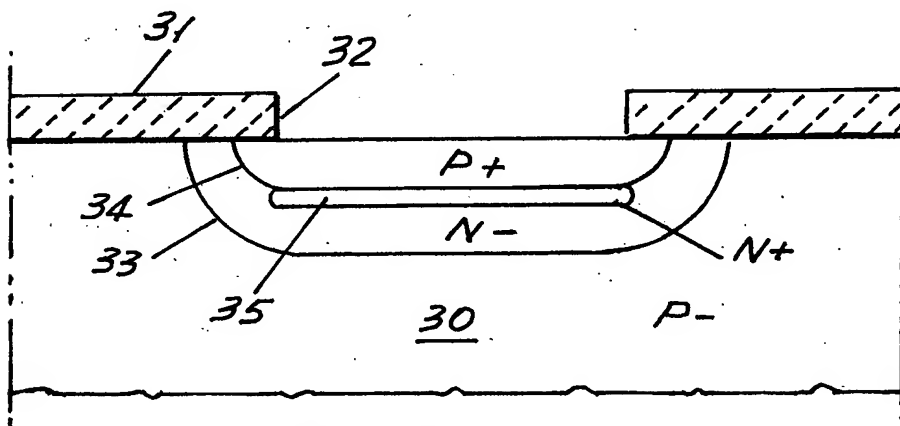


FIG. 4